



Application Serial No. 10/643,680
Filing Date August 18, 2003
Inventor Brenda D. Kraus et al.
Assignee Micron Technology, Inc.
Group Art Unit 1762
Examiner Brian K. Talbot
Attorney's Docket No. MI22-2310
Customer No. 021567
Title: Atomic Layer Deposition Methods of Forming Conductive Metal Nitride
Comprising Layers

RESPONSE TO FEBRUARY 9, 2007 FINAL OFFICE ACTION
PRELIMINARY AMENDMENT TO ACCOMPANY RCE FILING

To: Mail Stop RCE
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Responsive to the Final Office Action dated February 9, 2007,
Applicant amends and remarks as follows:

AMENDMENTS